



Attorney's Docket No.: 07977-258001 / US4448

2813
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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shinji Maekawa
Serial No. : 09/724,403
Filed : November 27, 2000
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH
TENSILE STRESS (AS AMENDED)

Art Unit : 2813
Examiner : Yennhu B. Huynh

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JANUARY 14, 2004

Please amend the above-identified application as follows:

Amendments to the Specification begin at page 2 of this paper.

Remarks/Arguments begin at page 3 of this paper.